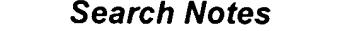


<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/749,219	KIM, KI-CHANG
	<b>Examiner</b> Joselynn Y. Sliteris	<b>Art Unit</b> 3616

**SEARCHED**

<b>INTERFERENCE SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>